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PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Lars Markwort	05/23/2012
Pierre-Yves Guittet	05/23/2012

RECEIVING PARTY DATA

Name:	Nanda Technologies GmbH	
Street Address:	Lise-Meitner-Strasse 3	
City:	Unterschleissheim	
State/Country:	GERMANY	
Postal Code:	85716	

PROPERTY NUMBERS Total: 2

Property Type	Number
Application Number:	13457219
Application Number:	61480279

CORRESPONDENCE DATA

Fax Number: (408)378-7770 Phone: 4083787777

Email: dchan@svpatentgroup.com

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent via US

Mail.

Correspondent Name: Silicon Valley Patent Group LLP

Address Line 1: 4010 Moorpark Avenue

Address Line 2: Suite 210

Address Line 4: San Jose, CALIFORNIA 95117

ATTORNEY DOCKET NUMBER:	NAN279 US
NAME OF SUBMITTER:	Michael J. Halbert

Total Attachments: 2

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PATENT REEL: 028259 FRAME: 0303 OP \$80,00 13457219

Attorney Docket No.: NAN279 US

ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, I:

Lars Markwort of Dachauer Strasse 59D, 85778 Haimhausen, Germany;

Pierre-Yves Guittet of Lise-Meitner-Strasse 3, 85716 Unterschleissheim, Germany;

hereby sell, assign and transfer to Nanda Technologies GmbH, a German corporation, having a place of business at Lise-Meitner-Strasse 3, 85716 Unterschleissheim, Germany, its successors and assigns, the entire right, title and interest throughout the world in my invention for which I have executed a United States patent application entitled

METHODS OF INSPECTING AND MANUFACTURING SEMICONDUCTOR WAFERS

with U.S. Patent Application Serial No. 13/457,219, filed April 26, 2012, and all provisional applications relating thereto, together with U.S. Provisional Patent Application Serial No. 61/480,279, filed April 28, 2011, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; I authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from me; I agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, its successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and I request that the United States Patent and Trademark Office issue all patents granted for said invention to the above-named assignee, its successors and assigns.

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Second Joint Inventor	
Executed this <u>ZS</u> day of	1AY , 2012.
State of	Stenature of Pierre-Yves Guittet
County of	SS.
Personally appeared Pierre-Yves Guitt whose name is subscribed to the within	(Notary's Name) et who proved to me on the basis of satisfactory evidence to be the person instrument and acknowledged to me that he/she executed the same in his/her signature on the instrument the person, or the entity upon behalf of which the
I certify under PENALTY OF PERJUR and correct. WITNESS my hand and official seal.	Y under the laws of the State of California that the foregoing paragraph is true
	SIGNATURE OF NOTARY

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PATENT REEL: 028259 FRAME: 0305